505315893 02/06/2019

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PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:NEW ASSIGNMENTNATURE OF CONVEYANCE:ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date				
MASASHIGE IWATA	12/19/2018				
HIROMICHI IKEUCHI	12/19/2018				

RECEIVING PARTY DATA

Name:	DAIFUKU CO., LTD.
Street Address:	2-11, MITEJIMA 3-CHOME, NISHI-YODOGAWA-KU
City:	OSAKA-SHI, OSAKA
State/Country:	JAPAN
Postal Code:	555-0012

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	16268883

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER:	MM12010US
NAME OF SUBMITTER:	MICHAEL A. JAFFE
SIGNATURE:	/Michael A. Jaffe/
DATE SIGNED:	02/06/2019

Total Attachments: 2

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PATENT 505315893 REEL: 048251 FRAME: 0780

For:

U.S. Rights U.S. Application

By:

Inventors

ASSIGNMENT OF INVENTION

In consideration of the payment by ASSIGNEE to ASSIGNOR(S) of the sum of Ten Dollars (\$10.00), the receipt of which is hereby acknowledged, and for other good and valuable consideration,

ASSIGNOR(S)	:
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Name:

Masashige IWATA

Address:

c/o DAIFUKU CO., LTD., Shiga Works,

1225, Nakazaiji, Hino-cho, Gamo-gun,

Shiga 529-1692 Japan

Nationality: Japan

Name:

Hiromichi IKEUCHI

Address:

c/o DAIFUKU CO., LTD., Shiga Works,

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Nationality: Japan

hereby sell, assign and transfer to

ASSIGNEE:

Name:

DAIFUKU CO., LTD.

Address:

2-11, Mitejima 3-chome, Nishi-yodogawa-ku,

Osaka-shi, Osaka 555-0012 Japan

Country of Formation:

Japan

and the successors, assigns and legal representatives of the ASSIGNEE the entire right, title and interest for the United States and its territorial possessions in and to any and all improvements which are disclosed in the invention entitled:

CONVEYANCE FACILITY

and which is found in (37 C.F.R.	. §3.21) U.S. patent	application	executed or	even	date	herev	vith c	or [] ir
Application No	, filed on				and,	in	and	to,	all
Letters Patent to be obtained for	r said invention by	the above	application	or any	con	tinuat	tion,	divisi	ion,
renewal, or substitute thereof, and	l as to letters patent a	any reissue o	or re-examin	ation t	hereo	f.			

ASSIGNOR(S) hereby covenant(s) that no assignment, sale, agreement or encumbrance has been or will be made or entered into which would conflict with this assignment.

Assignment of Invention—page 1 of 2

ASSIGNOR(S) further covenant(s) that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said invention and said Letters Patent and legal equivalents as may be known and accessible to ASSIGNOR(S) and will testify as to the same in any interference, litigation or proceeding related thereto and will promptly execute and deliver to ASSIGNEE or its legal representatives any and all papers, instruments or affidavits required to apply for, obtain, maintain, issue and enforce said application, said invention and said Letters Patent and said equivalents thereof which may be necessary or desirable to carry out the purposes thereof.

ASSIGNOR(S) hereby grant(s) the firm of Kusner & Jaffe the power to insert or complete on this assignment document any information, including application number and filing date, which may be necessary or desirable in order to comply with the rules of the U.S. Patent and Trademark Office for recordation of this document.

I/We have hereunto set hand on the date(s) set forth below.

Data	December	19	2018
Date:	DECEMBEL	- 11.	7010.

Masashige Twata

Signature of Masashige IWATA

Date: December 19, 2018

Himmichi Ikenchi

Signature of Hiromichi IKEUCHI